

The documentation and process conversion measures necessary to comply with this document shall be completed by 18 February 2014.

INCH-POUND

MIL-PRF-19500/687C  
 18 December 2013  
 SUPERSEDING  
 MIL-PRF-19500/687B  
 3 October 2008

PERFORMANCE SPECIFICATION SHEET

\* SEMICONDUCTOR DEVICE, FIELD EFFECT RADIATION HARDENED  
 TRANSISTOR, N-CHANNEL SILICON,  
 TYPES 2N7509, 2N7510, AND 2N7511, JANTXVD, R AND JANSD, R

This specification is approved for use by all Departments and Agencies of the Department of Defense.

The requirements for acquiring the product described herein shall consist of this specification sheet and MIL-PRF-19500.

1. SCOPE

1.1 Scope. This specification covers the performance requirements for a N-channel, enhancement-mode, MOSFET, radiation hardened (total dose and single event effects (SEE) characterization), power transistor intended for use in high density power switching applications. Two levels of product assurance are provided for each device type as specified in MIL-PRF-19500.

1.2 Physical dimensions. See figure 1, (TO-254).

1.3 Maximum ratings. T<sub>A</sub> = +25°C, unless otherwise specified.

Type	P <sub>T</sub> (1) T <sub>C</sub> = +25°C	V <sub>DS</sub>	V <sub>DG</sub>	V <sub>GS</sub>	R <sub>θJC</sub> max	I <sub>D1</sub> (2) (3) T <sub>C</sub> =+25°C	I <sub>D2</sub> (2) (3) T <sub>C</sub> = +100°C	I <sub>S</sub>	I <sub>DM</sub>	T <sub>J</sub> and T <sub>STG</sub>	V <sub>ISO</sub> 70,000 ft. altitude
	W	V dc	V dc	V dc	°C/W	A dc	A dc	A dc	A (pk)	°C	V dc
2N7509	192	100	100	±30	0.65	70	55	70	200	-55	N/A
2N7510	192	200	200	±30		53	34	53	200	to	N/A
2N7511	192	250	250	±30		42	27	42	160	+150	250

(1) Derate linearly 1.54 W/°C for T<sub>C</sub> > +25°C.

(2) The following formula derives the maximum theoretical I<sub>D</sub> limit. I<sub>D</sub> is limited by package and internal wires and may be limited by pin diameter:

$$I_D = \sqrt{\frac{T_{JM} - T_C}{(R_{\theta IC}) \times (R_{DS(on)} \text{ at } T_{JM})}}$$

(3) See figure 2, maximum drain current graph.

\* Comments, suggestions, or questions on this document should be addressed to DLA Land and Maritime, ATTN: VAC, P.O. Box 3990, Columbus, OH 43218-3990, or emailed to [Semiconductor@dla.mil](mailto:Semiconductor@dla.mil). Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at <https://assist.dla.mil>.

1.4 Primary electrical characteristics at T<sub>C</sub> = +25°C.

Type	Min V <sub>(BR)DSS</sub> V <sub>GS</sub> = 0 I <sub>D</sub> = 1.0 mA dc	V <sub>GS(TH)1</sub> V <sub>DS</sub> = V <sub>GS</sub> I <sub>D</sub> = 1.0 mA dc		Max I <sub>DSS1</sub> V <sub>GS</sub> = 0 V <sub>GS</sub> = 80% of rated V <sub>DS</sub>	Max r <sub>DS(on)</sub> (1) V <sub>GS</sub> = 12V		I <sub>AS</sub>
					T <sub>J</sub> = 25°C at I <sub>D2</sub>	T <sub>J</sub> = 125°C at I <sub>D2</sub>	
	V dc	V dc		μA dc	Ω	Ω	A (pk)
		Min	Max				
2N7509	100	2.0	4.5	25	0.0115	0.021	170
2N7510	200				0.034	0.065	110
2N7511	250				0.049	0.096	85

(1) Pulsed (see 4.5.1).

## 2. APPLICABLE DOCUMENTS

2.1 General. The documents listed in this section are specified in sections 3, 4, or 5 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3, 4, or 5 of this specification, whether or not they are listed.

2.2 Government documents.

2.2.1 Specifications, standards, and handbooks. The following specifications, standards, and handbooks form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

## DEPARTMENT OF DEFENSE SPECIFICATIONS

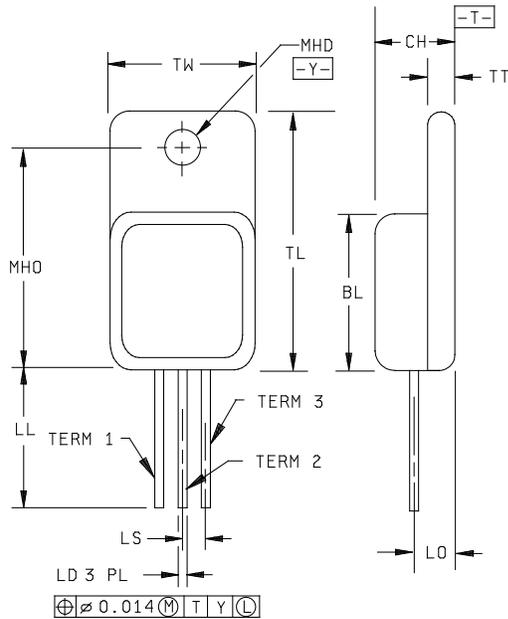
MIL-PRF-19500 - Semiconductor Devices, General Specification for.

## DEPARTMENT OF DEFENSE STANDARDS

MIL-STD-750 - Test Methods for Semiconductor Devices.

\* (Copies of these documents are available online at <http://quicksearch.dla.mil> or <https://assist.dla.mil> or from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

\* 2.3 Order of precedence. In the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.



Ltr	Dimensions			
	Inches		Millimeters	
	Min	Max	Min	Max
BL	.535	.545	13.59	13.84
CH	.249	.260	6.32	6.60
LD	.035	.045	0.89	1.14
LL	.510	.570	12.95	14.48
LO	.150 BSC		3.81 BSC	
LS	.150 BSC		3.81 BSC	
MHD	.139	.149	3.53	3.78
MHO	.665	.685	16.89	17.40
TL	.790	.800	20.07	20.32
TT	.040	.050	1.02	1.27
TW	.535	.545	13.59	13.84
Term 1	Drain			
Term 2	Source			
Term 3	Gate			

NOTES:

1. Dimensions are in inches.
2. Millimeters are given for general information only.
3. All terminals are isolated from case.
4. Die to base is BeO isolated, terminals to case ceramic (AL<sub>2</sub>O<sub>3</sub>) isolated.
5. In accordance with ASME Y14.5M, diameters are equivalent to φx symbology.

FIGURE 1. Physical dimensions for TO-254.

### 3. REQUIREMENTS

3.1 General. The individual item requirements shall be as specified in MIL-PRF-19500 and as modified herein.

3.2 Qualification. Devices furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturers list before contract award (see 4.2 and 6.3).

3.3 Abbreviations, symbols, and definitions. Abbreviations, symbols, and definitions used herein shall be as specified in MIL-PRF-19500 and as follows.

$I_{AS}$	Rated avalanche current, non-repetitive.
nC	nano coulomb.

3.4 Interface and physical dimensions. The interface and physical dimensions shall be as specified in MIL-PRF-19500, and [figure 1](#) (TO-254AA) herein. Methods used for electrical isolation of the terminals shall employ materials that contain a minimum of 90 percent  $Al_2O_3$  (ceramic).

3.4.1 Lead finish. Unless otherwise specified, lead finish shall be solderable in accordance with MIL-PRF-19500, MIL-STD-750, and herein. Where a choice of lead finish is desired, it shall be specified in the acquisition document (see [6.2](#)).

3.5 Marking. Marking shall be in accordance with MIL-PRF-19500.

3.6 Electrical performance characteristics. Unless otherwise specified herein, the electrical performance characteristics are as specified in paragraph [1.3](#), [1.4](#), and [table I](#).

3.7 Electrical test requirements. The electrical test requirements shall be as specified in [table I](#).

3.8 Electrostatic discharge protection. The devices covered by this specification require electrostatic discharge protection.

3.8.1 Handling. MOS devices must be handled with certain precautions to avoid damage due to the accumulation of static charge. However, the following handling practices are recommended.

- a. Devices should be handled on benches with conductive handling devices.
- b. Ground test equipment, tools and personnel handling devices.
- c. Do not handle devices by the leads.
- d. Store devices in conductive foam or carriers.
- e. Avoid use of plastic, rubber or silk in MOS areas.
- f. Maintain relative humidity above 50 percent if practical.
- g. Care should be exercised during test and troubleshooting to apply not more than maximum rated voltage to any lead.
- h. Gate must be terminated to source,  $R \leq$  or 100 k ohms, whenever bias voltage is applied drain to source.

3.9 Workmanship. Semiconductor devices shall be processed in such a manner as to be uniform in quality and shall be free from other defects that will affect life, serviceability, or appearance.

#### 4. VERIFICATION

4.1 Classification of inspections. The inspection requirements specified herein are classified as follows:

- a. Qualification inspection (see [4.2](#)).
- b. Screening (see [4.3](#)).
- c. Conformance inspection (see [4.4](#) and tables I and II).

4.2 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-19500. Alternate flow is allowed for qualification inspection in accordance with MIL-PRF-19500.

4.2.1 Group E qualification. Group E inspection shall be performed for qualification or re-qualification only. In case qualification was awarded to a prior revision of the specification sheet that did not request the performance of [table III](#) tests, the tests specified in [table III](#) herein that were not performed in the prior revision shall be performed on the first inspection lot of this revision to maintain qualification.

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\* 4.3 Screening (JANS and JANTXV levels only). Screening shall be in accordance with table E-IV of MIL-PRF-19500, and as specified herein. The following measurements shall be made in accordance with table I herein. Devices that exceed the limits of table I herein shall not be acceptable.

Screen (see table E-IV of MIL-PRF-19500) (1) (2)	Measurement	
	JANS	JANTXV
(3)	Gate stress test (see 4.3.1)	Gate stress test (see 4.3.1)
(3)	Method 3470 of MIL-STD-750, (see 4.3.2)	Method 3470 of MIL-STD-750, (see 4.3.2)
(3) 3c	Method 3161 of MIL-STD-750, (see 4.3.3)	Method 3161 of MIL-STD-750, (see 4.3.3)
7	Optional.	Optional.
9	$I_{GSSF1}$ , $I_{GSSR1}$ , $I_{DSS1}$ subgroup 2 of table I herein	$I_{GSSF1}$ , $I_{GSSR1}$ , $I_{DSS1}$ subgroup 2 of table I herein
10	Method 1042 of MIL-STD-750, test condition B	Method 1042 of MIL-STD-750, test condition B
11	$I_{GSSF1}$ , $I_{GSSR1}$ , $I_{DSS1}$ , $r_{DS(ON)1}$ , $V_{GS(TH)1}$ Subgroup 2 of table I herein. $\Delta I_{GSSF1} = \pm 20$ nA dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta I_{GSSR1} = \pm 20$ nA dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta I_{DSS1} = \pm 25$ $\mu$ A dc or $\pm 100$ percent of initial value, whichever is greater.	$I_{GSSF1}$ , $I_{GSSR1}$ , $I_{DSS1}$ , $r_{DS(ON)1}$ , $V_{GS(TH)1}$ Subgroup 2 of table I herein.
12	Method 1042 of MIL-STD-750, test condition A, 240 hours minimum.	Method 1042 of MIL-STD-750, test condition A, 160 hours minimum.
13	Subgroups 2 and 3 of table I herein $\Delta I_{GSSF1} = \pm 20$ nA dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta I_{GSSR1} = \pm 20$ nA dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta I_{DSS1} = \pm 25$ $\mu$ A dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta r_{DS(ON)1} = \pm 20$ percent of initial value. $\Delta V_{GS(TH)1} = \pm 20$ percent of initial value.	Subgroup 2 of table I herein $\Delta I_{GSSF1} = \pm 20$ nA dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta I_{GSSR1} = \pm 20$ nA dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta I_{DSS1} = \pm 25$ $\mu$ A dc or $\pm 100$ percent of initial value, whichever is greater. $\Delta r_{DS(ON)1} = \pm 20$ percent of initial value. $\Delta V_{GS(TH)1} = \pm 20$ percent of initial value.
14	Required.	Required.
17	For TO-254 packages: Method 1081 of MIL-STD-750 (see 4.3.4), Endpoints: Subgroup 2 of table I herein.	For TO-254 packages: Method 1081 of MIL-STD-750 (see 4.3.4), Endpoints: Subgroup 2 of table I herein.

(1) At the end of the test program,  $I_{GSSF1}$ ,  $I_{GSSR1}$ , and  $I_{DSS1}$  are measured.

(2) An out-of-family program to characterize  $I_{GSSF1}$ ,  $I_{GSSR1}$ ,  $I_{DSS1}$ , and  $V_{GS(th)1}$  shall be invoked.

(3) Shall be performed anytime after temperature cycling, screen 3a; JANTX and JANTXV levels do not need to be repeated in screening requirement.

4.3.1 Gate stress test. Apply  $V_{GS} = 45$  V minimum for  $t = 250$   $\mu$ s minimum.

4.3.2 Single pulse avalanche energy ( $E_{AS}$ ).

- a.  $I_{AS}$  shall be as specified in 1.4 herein.
- b.  $L = 0.1$  mH.
- c. Gate to source resistor ( $25 \text{ ohms} \leq R_{GS} \leq 200 \text{ ohms}$ ).
- d.  $E_{AS} = 1/2 LI_{AS}^2$ .
- e.  $V_{DD} = 50$  V to 150 V dc.
- f. Initial junction temperature = +25°C, -5°C, +10°C.

4.3.3 Thermal impedance ( $V_{SD}$  measurement). The delta  $V_{SD}$  measurement shall be performed in accordance with method 3161 of MIL-STD-750. The delta  $V_{SD}$  conditions ( $I_H$  and  $V_H$ ) and maximum limit shall be derived by each vendor from the thermal response curves (see figure 3) and shall be specified in the certificate of conformance prior to qualification. The following parameter measurements shall apply:

- a. Measuring current ( $I_M$ ).....10 mA.
- b. Heating time ( $t_H$ ).....100 ms.
- c. Measurement time delay ( $t_{MD}$ ).....30 - 60  $\mu$ s.
- d. Sample window time ( $t_{SW}$ ).....10  $\mu$ s maximum.

\* 4.3.4 Dielectric withstanding voltage.

- a. Magnitude of test voltage.....900 V dc.
- b. Duration of application of test voltage.....15 seconds (min).
- c. Points of application of test voltage.....All leads to case (bunch connection).
- d. Method of connection.....Mechanical.
- e. Kilovolt-ampere rating of high voltage source.....1,200 V/1.0 mA (min).
- f. Maximum leakage current.....1.0 mA.
- g. Voltage ramp up time.....500 V/second.

4.4 Conformance. Conformance inspection shall be in accordance with MIL-PRF-19500. Alternate flow is allowed for conformance inspection in accordance with MIL-PRF-19500.

4.4.1 Group A inspection. Group A inspection shall be conducted in accordance with table E-V of MIL-PRF-19500 and table I herein.

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4.4.2 Group B inspection. Group B inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-VIa (JANS) and in table E-VIb (JANTXV) of MIL-PRF-19500, and 4.4.2.1 and 4.4.2.2 herein. Electrical measurements (end-points) shall be in accordance with table 1, subgroup 2 herein. Delta  $V_{SD}$  measurements shall be in accordance with [table IV](#) herein.

\* 4.4.2.1 Group B inspection, table E-VIa (JANS) of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
B3	1051	Test condition F or G, 100 cycles.
* B4	1042	Intermittent operation life, condition D. No heat sink or forced-air cooling on the device shall be permitted during the on cycle; $t_{on}$ = 30 seconds minimum.
B5	1042	Accelerated steady-state reverse bias, condition A.
B5	1042	Accelerated steady-state gate bias, condition B.
B6	3161	Thermal resistance, see 4.5.2.

\* 4.4.2.2 Group B inspection, table E-VIb (JANTXV) of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
* B3	1042	Intermittent operation life, condition D. No heat sink or forced-air cooling on the device shall be permitted during the on cycle; $t_{on}$ = 30 seconds minimum.
B5	3161	Thermal resistance, see 4.5.2.

\* 4.4.3 Group C inspection. Group C inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-VII of MIL-PRF-19500 and as follows. Electrical measurements (end-points) and delta requirements shall be in accordance with the applicable steps of [table IV](#) herein.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
C2	2036	Terminal strength, test condition A, weight = 10 pounds, $t$ = 15 seconds.
C5	3161	See 4.5.2.
* C6	1042	Intermittent operation life, condition D. No heat sink or forced-air cooling on the device shall be permitted during the on cycle; $t_{on}$ = 30 seconds minimum.

4.4.4 Group D inspection. Group D inspection shall be conducted in accordance with table E-VIII of MIL-PRF-19500 and [table II](#) herein.

4.4.4.1 Design parameters. Not tested on a per lot basis. Design shall be such that the devices shall be capable of meeting the requirements in SEE safe operating area graphs.

4.4.5 Group E inspection. Group E inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-IX of MIL-PRF-19500 and as specified in [table III](#) herein. Electrical measurements (end points) and delta requirements shall be in accordance with the applicable steps of [table IV](#) herein.

4.5 Methods of inspection. Methods of inspection shall be as specified in the appropriate tables and as follows.

4.5.1 Pulse measurements. Conditions for pulse measurement shall be as specified in section 4 of MIL-STD-750.

4.5.2 Thermal resistance. Thermal resistance measurements shall be performed in accordance with method 3161 of MIL-STD-750. The maximum limit of  $R_{\theta JC} = 0.65^{\circ}\text{C/W}$ . The following parameters shall apply:

- a. Measuring current ( $I_M$ ).....10 mA.
- b. Drain heating current ( $I_H$ ).....4 A.
- c. Heating time ( $t_H$ ).....Steady-state (see method 3161 of MIL-STD-750).
- d. Drain-source heating voltage ( $V_H$ ).....25 V.
- e. Measurement time delay ( $t_{MD}$ ).....30 to 60  $\mu\text{s}$ .
- f. Sample window time ( $t_{SW}$ ).....10  $\mu\text{s}$  maximum.

TABLE I. Group A inspection.

Inspection 1/	MIL-STD-750		Symbol	Limits		Units
	Method	Conditions		Min	Max	
<u>Subgroup 1</u>						
Visual and mechanical inspection	2071					
<u>Subgroup 2</u>						
Breakdown voltage drain to source 2N7509 2N7510 2N7511	3407	$V_{GS} = 0V$ , $I_D = 1 \text{ mA dc}$ , bias condition C	$V_{(BR)DSS}$	100 200 250		V dc V dc V dc
Gate to source voltage (threshold)	3403	$V_{DS} = V_{GS}$ , $I_D = 1 \text{ mA dc}$	$V_{GS(TH)1}$	2.0	4.5	V dc
Gate current	3411	$V_{GS} = +30V \text{ dc}$ , bias condition C, $V_{DS} = 0V$	$I_{GSSF1}$		+100	nA dc
Gate current	3411	$V_{GS} = -30V \text{ dc}$ , bias condition C, $V_{DS} = 0V$	$I_{GSSR1}$		-100	nA dc
Drain current	3413	$V_{GS} = 0V \text{ dc}$ , bias condition C, $V_{DS} = 80 \text{ percent of rated } V_{DS}$	$I_{DSS1}$		25	$\mu\text{A dc}$
Static drain to source on-state resistance 2N7509 2N7510 2N7511	3421	$V_{GS} = 12V \text{ dc}$ , condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)1}$		0.0115 0.034 0.049	$\Omega$ $\Omega$ $\Omega$
Static drain to source on-state voltage 2N7509 2N7510 2N7511	3405	$V_{GS} = 12V \text{ dc}$ , condition A, pulsed (see 4.5.1), $I_D = I_{D1}$	$V_{DS(ON)}$		0.84 1.91 2.18	V dc V dc V dc
Forward voltage	4011	$V_{GS} = 0V \text{ dc}$ , condition A, pulsed (see 4.5.1), $I_D = I_{D1}$	$V_{SD}$		1.2	V dc

See footnote at end of table.

TABLE I. Group A inspection - Continued.

Inspection 1/  <u>Subgroup 3</u>	MIL-STD-750		Symbol	Limits		Units
	Method	Conditions		Min	Max	
High temperature operation		$T_C = T_J = +125^\circ\text{C}$				
Gate current	3411	$V_{GS} = \pm 30\text{V dc}$ , bias condition C, $V_{DS} = 0\text{V}$	$I_{GSS2}$		$\pm 200$	nA dc
Drain current	3413	$V_{GS} = 0\text{V dc}$ , bias condition C, $V_{DS} = 80$ percent of rated $V_{DS}$	$I_{DSS2}$		0.250	mA dc
Static drain to source on-state resistance 2N7509 2N7510 2N7511	3421	$V_{GS} = 12\text{V dc}$ , condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)2}$		0.021 0.065 0.096	$\Omega$ $\Omega$ $\Omega$
Gate to source voltage (threshold)	3403	$V_{DS} = V_{GS}$ , $I_D = 1$ mA dc	$V_{GS(TH)2}$	1.0		V dc
Low temperature operation		$T_C = T_J = -55^\circ\text{C}$				
Gate to source voltage (threshold)	3403	$V_{DS} = V_{GS}$ , $I_D = 1$ mA dc	$V_{GS(TH)3}$		5.5	V dc
<u>Subgroup 4</u>						
Switching time test	3472	$I_D = I_{D1}$ , $V_{GS} = 12$ V dc, $R_G = 2.35 \Omega$ , $V_{DD} = 50$ percent of rated $V_{DS}$				
Turn-on delay time 2N7509 2N7510 2N7511			$t_{D(on)}$		35 35 35	ns ns ns
Rise time 2N7509 2N7510 2N7511			$t_R$		140 140 70	ns ns ns

See footnote at end of table.

TABLE I. Group A inspection – Continued.

Inspection 1/	MIL-STD-750		Symbol	Limits		Units
	Method	Conditions		Min	Max	
<u>Subgroup 4</u> - Continued.						
Turn-off delay time			$t_{D(off)}$		60	ns
2N7509					65	ns
2N7510					70	ns
2N7511						
Fall time			$t_f$		20	ns
2N7509					15	ns
2N7510					15	ns
2N7511						
<u>Subgroup 5</u>						
Safe operating area test (high voltage)	3474	See <a href="#">figure 4</a> , $t_p = 10$ ms min. $V_{DS} = 80$ percent of max. rated $V_{DS}$ ( $V_{DS} \leq 200$ V)				
Electrical measurements		See <a href="#">table I</a> , subgroup 2				
<u>Subgroup 6</u>						
Not applicable						
<u>Subgroup 7</u>						
Gate charge	3471	Condition A or B				
On-state gate charge			$Q_{G(ON)}$		150	nC
2N7509					115	nC
2N7510					115	nC
2N7511						
Gate to source charge			$Q_{GS}$		45	nC
2N7509					60	nC
2N7510					45	nC
2N7511						

See footnote at end of table.

TABLE I. Group A inspection – Continued.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limits		Units
	Method	Conditions		Min	Max	
<u>Subgroup 7</u> - Continued.						
Gate to drain charge			$Q_{GD}$			
2N7509					55	nC
2N7510					30	nC
2N7511					45	nC
Reverse recovery time	3473	$di/dt = 100 \text{ A}/\mu\text{s}, V_{DD} \leq 50 \text{ V},$ $I_D = I_{D1}$	$t_{rr}$			
2N7509					290	ns
2N7510					375	ns
2N7511					590	ns

1/ For sampling plan, see MIL-PRF-19500.

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TABLE II. Group D inspection.

Inspection <u>1/ 2/ 3/ 4/ 5/</u>	MIL-STD-750		Symbol	Pre-irradiation limits		Post irradiation limits		Units
	Method	Conditions		Min.	Max.	Min.	Max.	
<u>Subgroup 1</u>								
Not applicable								
<u>Subgroup 2</u>		$T_C = +25^\circ\text{C}$						
Steady state total dose irradiation ( $V_{GS}$ bias)	1019	$V_{GS} = 12\text{V}, V_{DS} = 0\text{V}$						
Steady state total dose irradiation ( $V_{DS}$ bias)	1019	$V_{GS} = 0\text{V}, V_{DS} = 80$ percent of rated $V_{DS}$						
Breakdown voltage drain to source	3407	$V_{GS} = 0\text{V}, I_D = 1$ mA dc, bias condition C	$V_{(BR)DSS}$					
2N7509				100		100		V dc
2N7510				200		200		V dc
2N7511				250		250		V dc
Gate to source voltage (threshold)	3403	$V_{DS} = V_{GS}, I_D = 1$ mA dc	$V_{GS(TH)1}$	2.0	4.5	2.0	4.5	V dc
Gate current	3411	$V_{GS} = \pm 30\text{V}$ dc, $V_{DS} = 0\text{V}$ , bias condition C	$I_{GSS1}$		$\pm 100$		$\pm 100$	nA dc
Drain current	3413	$V_{GS} = 0\text{V}, V_{DS} = 80$ percent of rated $V_{DS}$ , bias condition C	$I_{DSS1}$		25		25	$\mu\text{A}$ dc
Static drain to source on-state resistance	3421	$V_{GS} = 12\text{V}$ dc, condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)1}$					
2N7509					0.0115		0.0115	$\Omega$
2N7510					0.034		0.034	$\Omega$
2N7511					0.049		0.049	$\Omega$
Static drain to source on-state voltage	3405	$V_{GS} = 12\text{V}$ dc, condition A, pulsed (see 4.5.1), $I_D = I_{D1}$	$V_{DS(ON)}$					
2N7509					0.84		0.84	V dc
2N7510					1.91		1.91	V dc
2N7511					2.18		2.18	V dc

1/ For sampling plan see MIL-PRF-19500.

2/ Electrical specifications are for 'D' and 'R' rad levels.

3/ Group D qualification may be performed prior to lot formation. Wafers qualified to these group D QCI requirements may be used for any other specification sheet utilizing the same die design.

4/ Separate samples shall be pulled for each bias.

5/ At the manufacturer's option, group D samples need not be subjected to all the screening tests, but shall be assembled in its qualified package or in any qualified package that the manufacturer has data to correlate the performance to the designated package.

\* TABLE III. Group E inspection (all quality levels) for qualification or re-qualification only.

Inspection 1/ 2/ 3/ 4/	MIL-STD-750		Qualification and large lot conformance inspection
	Method	Conditions	
<u>Subgroup 1</u>			45 devices c = 0
Temperature cycling (air to air)	1051	Test condition G, 500 cycles	
Hermetic seal	1071		
Fine leak			
Gross leak			
Electrical measurements		See <a href="#">table I</a> , subgroup 2 and <a href="#">table IV</a> , step 1	
<u>Subgroup 2</u> 1/			45 devices c = 0
Steady-state gate bias	1042	Test condition B; 1,000 hours	
Electrical measurements		See <a href="#">table I</a> , subgroup 2 and <a href="#">table IV</a> , step 1	
Steady state reverse bias	1042	Test condition A; 1,000 hours	
Electrical measurements		See <a href="#">table I</a> , subgroup 2 and <a href="#">table IV</a> , step 1	
<u>Subgroup 4</u>			
Thermal impedance		See MIL-PRF-19500.	
<u>Subgroup 5</u>			15 devices c = 0
Barometric pressure test (not required for $V_{BR(DSS)} \leq 200$ V)	1001	Test condition C	
2N7511		$V_{DS} = 250$ V; $I_{(ISO)} < 0.25$ mA	
<u>Subgroup 6</u>			
ESD	1020		

1/ A separate sample for each test may be pulled.

2/ Group E qualification of single event effect testing may be performed prior to lot formation. Wafers qualified to these group E QCI requirements may be used for any other specification utilizing the same die design.

3/ As a minimum, gate to source leakage and drain to source leakage are to be examined to verify the electrical performance of the DUT prior to and after test. At the manufacturer's option, the remaining static tests in [table IV](#), with the exception of step 8, may be performed.

4/ This sampling plan applies to each bias condition defined.

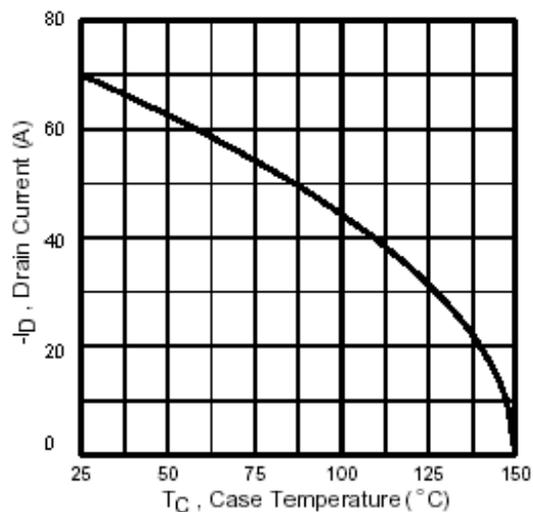
TABLE IV. Group A, B, C, and E delta measurements.

Step	Inspection <u>1/</u> <u>2/</u>	MIL-STD-750		Symbol	Limits		Units
		Method	Conditions		Min	Max	
1.	Thermal response	3161	See <a href="#">4.3.3</a>	$\Delta V_{SD}$		100	mV

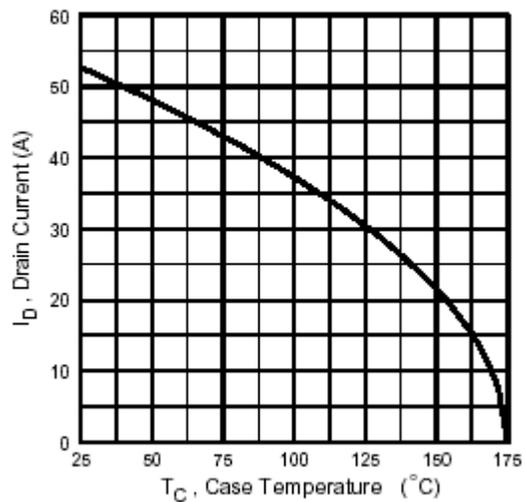
1/ The delta measurements for table VIa (JANS) of MIL-PRF-19500 are: Subgroup 4

2/ The delta measurements for table VII of MIL-PRF-19500 are: Subgroup 6.

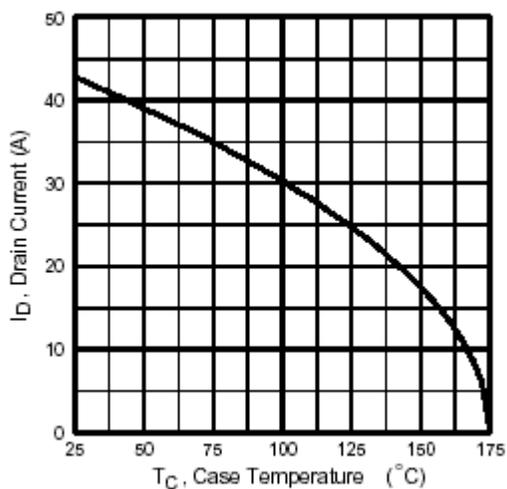
3/ The delta measurements for table IX of MIL-PRF-19500 are: Subgroups 1, 2, and 6.



2N7509



2N7510



2N7511

FIGURE 2. Maximum drain current vs case temperature graphs.

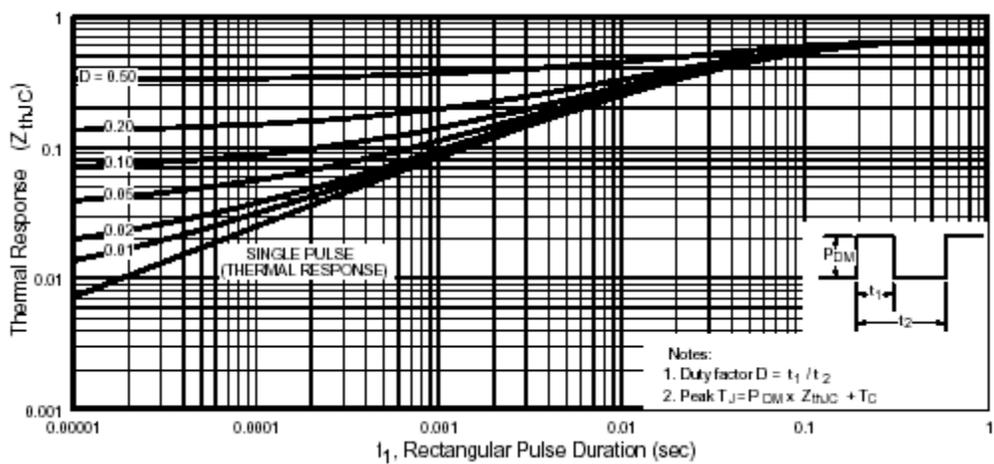


FIGURE 3. Thermal response curves.

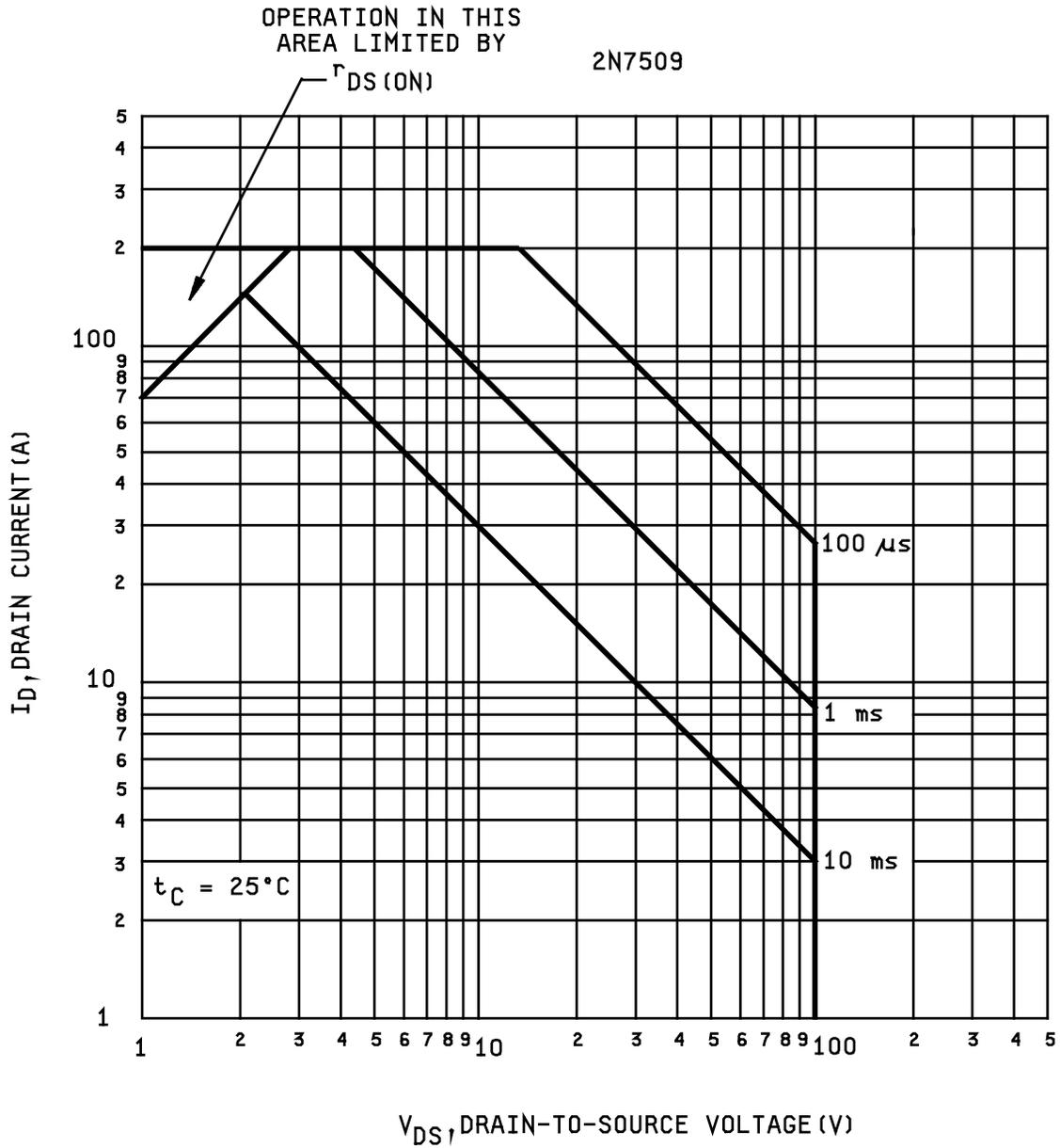


FIGURE 4. Safe operating area graphs.

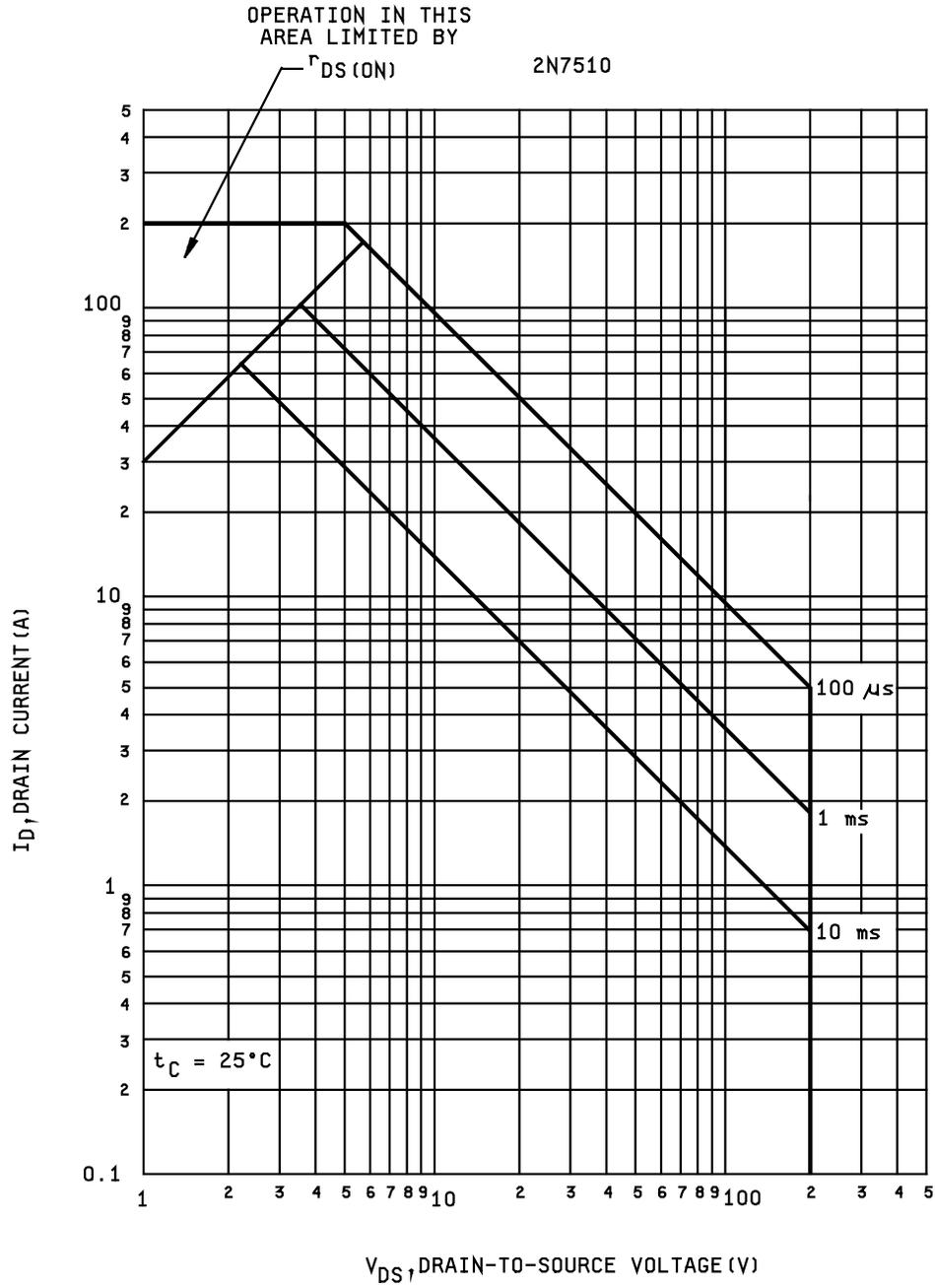


FIGURE 4. Safe operating area graphs –continued.

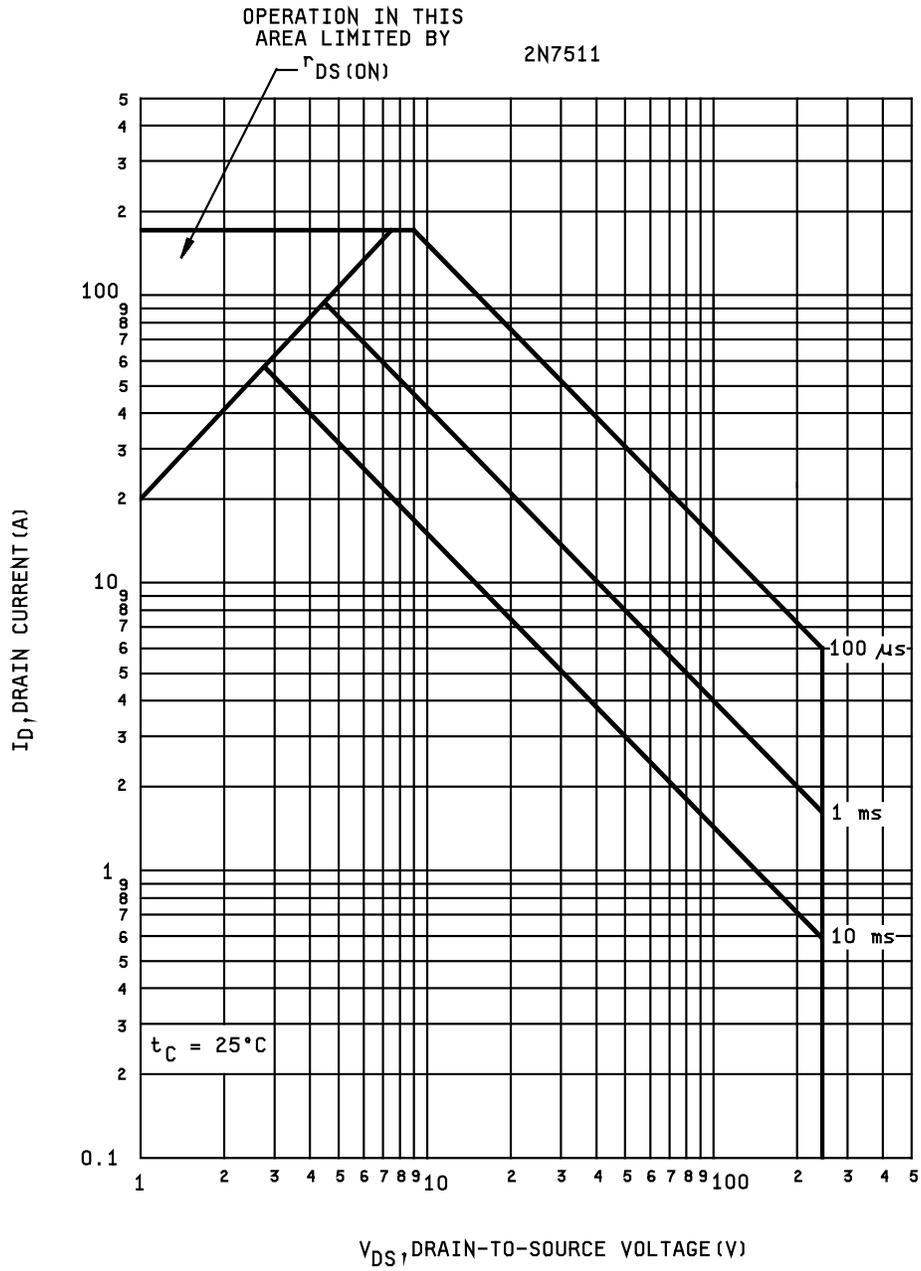


FIGURE 4. Safe operating area graphs – Continued.

5. PACKAGING

5.1 Packaging. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activities within the Military Service or Defense Agency, or within the Military Service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory. The notes specified in MIL-PRF-19500 are applicable to this specification.)

6.1 Intended use. Semiconductors conforming to this specification are intended for original equipment design applications and logistic support of existing equipment.

6.2 Acquisition requirements. Acquisition documents should specify the following:

- a. Title, number, and date of this specification.
- b. Packaging requirements (see 5.1).
- c. Lead finish (see 3.4.1).
- d. Product assurance level and type designator.
- e. For acquisition of RHA designated devices, table II, subgroup 1 testing of group D herein is optional. If subgroup 1 is desired, it should be specified in the contract.
- f. If specific SEE characterization conditions are desired (see section 6.6 and table IV), manufacturer's cage code should be specified in the contract or order.
- g. If SEE testing data is desired, it should be specified in the contract or order.

\* 6.3 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List (QML 19500) whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from DLA Land and Maritime, ATTN: VQE, P.O. Box 3990, Columbus, OH 43218-3990 or e-mail [vqe.chief@dla.mil](mailto:vqe.chief@dla.mil). An online listing of products qualified to this specification may be found in the Qualified Products Database (QPD) at <https://assist.dla.mil>.

6.4 Substitution information. Devices covered by this specification are substitutable for the manufacturer's and user's Part or Identifying Number (PIN). This information in no way implies that manufacturer's PINs are substitutable for the military PIN.

Generic P/N	Military P/N
FSGJ160	2N7509
FSGJ260	2N7510
FSGJ264	2N7511

6.5 Changes from previous issue. The margins of this specification are marked with asterisks to indicate where changes from the previous issue were made. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

\* 6.5.1 Manufacturer specific irradiation data. Each manufacturer qualified to this slash sheet has characterized its devices to the requirements of MIL-STD-750 method 1080 and as specified herein. Since each manufacturer's characterization conditions can be different and can vary by the version of method 1080 qualified to, the MIL-STD-750 method 1080 revision version date and conditions used by each manufacturer for characterization have been listed here (see [table V](#)) for information only. SEE conditions and figures listed in section 6 are current as of the date of this specification sheet, please contact the manufacturer for the most recent conditions.

\* TABLE V. Manufacturers characterization conditions - Continued.

Manufactures cage	Inspection	MIL-STD-750		Sample plan
		Method	Conditions	
<div style="border: 1px solid black; padding: 10px; width: fit-content; margin: 0 auto;">                     Upon qualification, all manufacturers should provide the verification test conditions to be added to this table.                 </div>				

1/ I<sub>GSSF1</sub>, I<sub>GSSR1</sub>, and I<sub>DSS1</sub> was examined before and following SEE irradiation to determine acceptability for each bias condition. Other test conditions in accordance with [table I](#), subgroup 2, may be performed at the manufacturer's option.

6.6 Changes from previous issue. The margins of this specification are marked with asterisks to indicate where changes from the previous issue were made. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

Custodians:  
 Army - CR  
 Navy - EC  
 Air Force - 85  
 NASA - NA  
 DLA - CC

Preparing activity:  
 DLA - CC  
 (Project 5961-2013-110)

Review activities:  
 Army - MI  
 Air Force - 99

\* NOTE: The activities listed above were interested in this document as of the date of this document. Since organizations and responsibilities can change, you should verify the currency of the information above using the ASSIST Online database at <https://assist.dla.mil>.